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Type of Paper transmitted: Response to Restriction Requirement

Applicant's Name: Fong SHI

Serial No. (Control No.): 10/630,778

Examiner: Phat X. Cao

Filing Date

July 31, 2003

Art Unit: 2814

Application Title:

NEAR HERMETIC PACKAGING OF GALLIUM ARSENIDE
SEMICONDUCTOR DEVICES AND MANUFACTURING
METHOD THEREFOR

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Attorney Docket No.: 60000500-1012

OFFICIAL

RESPONSE
GROUP ART UNIT 2814
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Fong SHI

Group Art Unit: 2814

Application No.: 10/630,778

Examiner: Phat X. Cao

Filed: July 31, 2003

For: NEAR HERMETIC PACKAGING OF GALLIUM ARSENIDE SEMICONDUCTOR
DEVICES AND MANUFACTURING METHOD THEREFOR

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement made April 6, 2004, concerning the above-identified matter, Applicant elects the invention recited in claims 1-18 (Group I) for examination on the merits without traverse.

Dated: April 29, 2004

Respectfully submitted,



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